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TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT (Under 37 CFR 1.97(b) or 1.97(c))		Docket No. FIS920040083US1	
In Re Application Of: William G. America			
Serial No. 10/709,776	Filing Date May 27, 2004	Examiner	Group Art Unit
Title: SEMICONDUCTOR DEVICE FORMED BY IN-SITU MODIFICATION OF DIELECTRIC LAYER AND RELATED METHODS			
<p>Address to: Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450</p> <p>37 CFR 1.97(b)</p> <p>1. <input checked="" type="checkbox"/> The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.</p> <p>37 CFR 1.97(c)</p> <p>2. <input type="checkbox"/> The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:</p> <p><input type="checkbox"/> the statement specified in 37 CFR 1.97(e);</p> <p>OR</p> <p><input type="checkbox"/> the fee set forth in 37 CFR 1.17(p).</p>			

TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT

(Under 37 CFR 1.97(b) (1.97(e)))

Docket No.
FIS920040083US1

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JUN 21 2004

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**SEMICONDUCTOR DEVICE FORMED BY IN-SITU MODIFICATION OF DIELECTRIC LAYER
AND RELATED METHODS****Payment of Fee**

(Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p))

- ☐ A check in the amount of _____ is attached.
- ☒ The Director is hereby authorized to charge and credit Deposit Account No. 09-0458 (IBM)
as described below.
- ☐ Charge the amount of _____
- ☒ Credit any overpayment.
- ☒ Charge any additional fee required.

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Patent and Trademark Office (F:

6/17/04

(Date)

James J. Cioffi
Signature

Typed or Printed Name of Person Signing Certificate

Certificate of Mailing by First Class MailI certify that this document and fee is being deposited
on 6-18-04 with the U.S. Postal Service
as first class mail under 37 C.F.R. 1.8 and is
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1450, Alexandria, VA 22313-1450.*Karen Cing-Mars*
Signature of Person Mailing CorrespondenceKaren Cing-Mars
Typed or Printed Name of Person Mailing Certificate***This certificate may only be used if paying by
deposit account.**

Dated:

Signature

James J. Cioffi
Reg. No. 51,564

CC:

